

<b>Notice of References Cited</b>	Application/Control No. 10/534,700	Applicant(s)/Patent Under Reexamination WITTMER ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"PROFIBUS Technology and Application - System Description" OCT. 2002
	V	"Field Device Integration" by Simon et al. IEEE 2001
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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